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FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L. L. P.

1300 I STREET, N. W. WASHINGTON, DC 20005-3315

202 • 408 • 4000 FACSIMILE 202 • 408 • 4400

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ATTORNEY DOCKET NO.: 04329.2350

Box Patent Application Assistant Commissioner for Patents Washington, D.C. 20231

New U.S. Patent Application
Title: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD
Inventor and Address:

1) Osamu ARISUMI Yokohama-shi, Japan

Sir:

We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

- 1. A check for \$768.00 representing the filing fee.
- 2. Application 51 pages, including 4 independent claims and 20 claims total.
- 3. Drawings 23 sheets of formal drawings containing 56 figures.
- 4. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with document attached.

This application is being filed under the provisions of 37 C.F.R. § 1.53(f). Applicant awaits notification from the Patent and Trademark Office of the time set for filing the Declaration.

Applicant claims the right to priority based on Japanese Patent Application No. 11-200901, filed on July 14, 1999.

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L. L. P. Assistant Commissioner for Patents

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Please accord this application a serial number and filing date.

The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Bv:

Richard V. Burgujian Reg. No. 31,744

RVB/FPD/sci Enclosures